

## Note of Retraction

Retraction of the Article: N. Sulitanu, F. Brinza, "*Electrodeposited Ni-Fe-S Films with High Resistivity for Magnetic Recording Devices*", Journal of Optoelectronics and Advanced Materials, Vol. 6, No. 2, pages 641-645 (June 2004).

This Article is being retracted by the Editor-in-Chief and the Board of Directors of Journal of Optoelectronics and Advanced Materials because of research and publication misconduct acts of the authors, which include plagiarism of the figures from the article: M. Takai, F. Mera, M. Kaseda, T. Osaka, "*Increasing the Resistivity of NiFeP Films by Means of Electrodeposition*", Journal of the Magnetism Society of Japan, 1998, Vol. 22, No. 4-2, pages 629-632.

The author F. Brinza has been informed about the ethical problems of the Article co-authored by him. He has agreed to the retraction of the Article. N. Sulitanu is deceased.

The Retraction Note has been published in Journal of Optoelectronics and Advanced Materials vol. 25, iss. (9-10), page 517 (2023).